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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kiyoshi Arita  
Serial No.: 10/716,965 Art Unit: 2813  
Filing Date: November 19, 2003  
Title: "METHOD OF MANUFACTURING SEMICONDUCTOR  
DEVICE PLASMA PROCESSING APPARATUS AND  
PLASMA PROCESSING METHOD"  
Docket No.: 36280

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va. 22313-1450

Sir/Madam:

In accordance with Rule 56, applicant is aware of the publications listed in the International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form 1449. A copy of each of the publications is enclosed herewith. The undersigned hereby certifies that each item of information contained in this Supplemental Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

If there are any fees resulting from this communication, please charge such fees to our Deposit Account No. 16-0820, Order No. 36280.

Respectfully submitted,  
PEARNE & GORDON LLP

By: \_\_\_\_\_

Jeffrey J. Sopko, Reg. No. 27676

1801 East 9th Street  
Suite 1200  
Cleveland, Ohio 44114-3108  
  
(216) 579-1700

May 12, 2004

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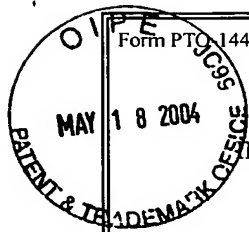
Jeffrey J. Sopko

Name of Attorney for Applicant(s)

05/12/2004

Date

Signature of Attorney



Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
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36280SERIAL NO.  
10/716,965INFORMATION DISCLOSURE CITATION  
BY APPLICANT  
(USE SEVERAL SHEETS IF NECESSARY)APPLICANT:  
Kiyoshi AritaFILING DATE:  
November 19, 2003GROUP ART UNIT:  
2813

## U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A	4,325,182	04/1982	Tefft et al.			
	B	5,275,958	01/1994	Ishikawa			
	C	5,693,182	12/1997	Mathuni			
	D	5,888,882	03/1999	Igel et al.			
	E	6,239,036 B1	05/2001	Arita et al.			
	F	US 2002/0061642 A1	05/2002	Haji et al.			
	G						
	H						
	I						
	J						
	K						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L						
	M						
	N						
	P						
	Q						

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	R	
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\*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.